PUBLICATIONS

A. BOOK(S)

1 | **K. Keskinbora**, *Prototyping Micro-and Nano-Optics with Focused Ion Beam Lithography*, SPIE Press – Spotlights, 2019

B. JOURNAL PAPERS

16 | J. Gräfe, P. Gruszecki, M. Zelent, M. Decker, **K. Keskinbora**, …, G. Schütz, *Direct observation of spin-wave focusing by a Fresnel lens*, Physical Review B 102 (2), 024420

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14 | L. Loetgering, M. Baluktsian, **K. Keskinbora**, …, S. Witte, *Generation and characterization of focused helical X-ray beams*, Science Advances, eaax8836, 6 (7), 2020

13 | L. Loetgering, M. Rose, **K. Keskinbora**, M. Baluktsian, …, T. Wilhein, *Correction of axial position uncertainty and systematic detector errors in ptychographic diffraction imaging*, Opt. Eng. 57 (8), 084106, 2018

12 | **K. Keskinbora***, U.T. Sanli, M. Baluktsian, C.Grévent, G. Schütz, *High-throughput Synthesis of High Resolution Modified Fresnel Zone Plate arrays via Ion Beam Lithography*, Beilstein Journal of Nanotechnology 9 (1), 2049-2056, 2018

11 | U. T. Sanli, H. Ceylan*, I. Bykova, M. Weigand, M. Sitti, G. Schütz, **K. Keskinbora***, 3D Nano-printed Kinoform X-ray Optics, Adv. Mater. 1802503, 2018

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7 | **K. Keskinbora**, A.-L. Robisch, M. Mayer, U. T. Sanli, C. Grévent, C. Wolter, M. Weigand, A. Szeghalmi, M. Knez, T. Salditt, G. Schütz, *Multilayer Fresnel zone plates for high energy radiation resolve 21 nm features at 1.2 keV* Opt. Express, 22 (15), 18440-18453, 2014

6 | **K. Keskinbora**, C. Grévent, U. Eigenthaler, M. Weigand, G. Schütz, *Rapid prototyping of Fresnel zone plates via direct Ga+ ion beam lithography for high resolution X-Ray imaging*, ACS Nano, 7 (11), 9788-9797, 2013

5 | **K. Keskinbora**, C. Grévent, M. Bechtel, M. Weigand, E. Goering, A. Nadzeyka, L. Peto, S. Rehbein, G. Schneider, R. Follath, J. Vila-Comamala, H. Yan, G. Schütz, *Ion beam lithography for Fresnel zone plates in X-ray microscopy* Opt. Express 21 (10), 11747-11756, 2013

4 | M. Mayer, **K. Keskinbora**, C. Grévent, A. Szeghalmi, M. Knez, M. Weigand, A. Snigirev, I. Snigireva, G. Schutz, *Efficient focusing of 8 keV X-rays with multilayer Fresnel zone*

plates fabricated by atomic layer deposition and focused ion beam milling J. Synchrotron Radiat. 20 (3), 433-440, 2013

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C. PROCEEDINGS

11 | I. Bykova, **K. Keskinbora**, U. Sanli, J. Gräfe, M. Bechtel, G. Yu, … Weigand, M. *Soft X-ray Ptychography for Imaging of Magnetic Domains and Skyrmions in Sub-100 nm Scales*. Microscopy & Microanalysis, 24(S2), 36-37.

10 | U. Sanli, H. Ceylan, C. Jiao, M. Baluktsian, Grevent, K. C., Hahn, ... **K. Keskinbora*** *New Concepts for 3D Optics in X-ray Microscopy*. Microscopy & Microanalysis, 24(S2), 292-293.

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2 | U. T. Sanli, **K. Keskinbora** and G. Schütz, *High Resolution Full Material Fresnel Zone Plate Array and Process for its Fabrication*, EU Patent, EPO 3282294, March 2020

1 | G. Schütz, C. Grévent, **K. Keskinbora**, M. Hirscher, *Method of producing a Fresnel Zone Plate for applications in high energy radiation*, US Patent, US9859028B2, 2018

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